

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Int. Appl No.: PCT/AU2003/001313

Applicant: Aberle, Armin Gerhard

Filed: October 7, 2003

Title: FABRICATION METHOD FOR
CRYSTALLINE
SEMICONDUCTOR FILMS ON
FOREIGN SUBSTRATES

Group Art
Unit: Not Yet Assigned

Examiner: Not Yet Assigned

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PRELIMINARY AMENDMENT

Mail Stop PCT
Commissioner for Patents
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Sir:

Prior to examining the above-identified U.S. national phase application of International patent application No. PCT/AU2003/001313, having a priority date of October 8, 2002, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims with begins on page 4 of this paper.

Remarks/Arguments begin on page 10 of this paper.